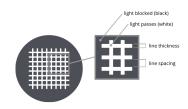


# PTGR050450P | DATASHEET

# **Grid pattern, Photolitography**



Opto Engineering® supplies a comprehensive range of projection patterns compatible with our LED illuminators.

PT projection patterns can be either laser-engraved, with 50  $\mu$ m geometrical accuracy, or photolitography-engraved for more demanding applications (2  $\mu$ m accuracy).



#### **SPECIFICATIONS**

Type		Grid
Process		Photolitography
Substrate		Soda lime glass
Coating		Chrome on glass
Line spacing	(mm)	0.45
Line thickness	(mm)	0.05
Dot size	(mm x mm)	-
Geometrical accuracy	(µm)	2
Edge sharpness	(µm)	1.4

#### **Circular aperture (LTPR)**

Active Area	(mm)	11
Number of lines		22 x 22
Max line length	(mm)	11

### **Square aperture (LTPRSM)**

Active Area	(mm)	8 x 8
Number of lines		16 x 16
Max line length	(mm)	8

#### **Mechanical specifications**

Diameter	(mm)	21
Thickness	(mm)	1.6

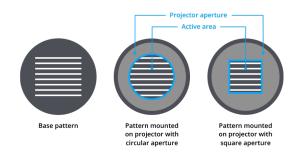
# **COMPATIBLE PRODUCTS**

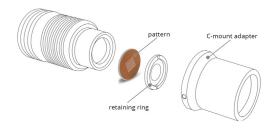
#### Full list of compatible products available here.



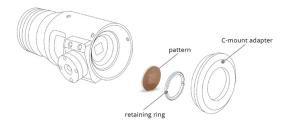
## A wide selection of innovative machine vision components.

#### PTPR AND ACTIVE AREA





Pattern projector with circular aperture disassembled.



Pattern projector with square aperture disassembled.